



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: Elkind et al.

Docket No.: TI-30785

Serial No.: 10/053,454

Art Unit: 2851

Filed: 10/25/01

Examiner: Sever, Andrew T

Title: Robust Integrated Surface Plasmon Resonance Sensor

AMENDMENT UNDER 37 CFR 1.111

June 1, 2004

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

MAILING CERTIFICATE UNDER 37 C.F.R. §1.8(A)

I hereby certify that the above correspondence is being deposited with the U.S. Postal Service on 6-1-04
as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450

Karen Vertz

Karen Vertz

6-1-04

Date

In response to the Office Action, dated 3/10/2004, in the above-identified patent application, please make the following amendments. They are respectfully submitted as a full and complete response to that Action. Charge any required fees to the deposit account of Texas Instruments Incorporated, Account No. 20-0668.